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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tsuga et al.
Serial No.: 10/085,725
Filing Date: 02/28/2002
Customer No.: 23494

Art Unit: 1746
Examiner: Kornakov, M.
Docket No.: TI-31621
Conf. No.: 1672

Title: METHOD AND DEVICE FOR REMOVING PARTICLES ON
SEMICONDUCTOR WAFERS

OFFICIAL

REQUEST FOR EXTENSION OF TIME

Commissioner of Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATION OF FACSIMILE TRANSMISSION	
<p>I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on the date shown below.</p> 	
<u>June 21, 2004</u> <u>Date</u>	
<u>Jacqueline J. Garner, Reg. No. 36,144</u>	

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner for an extension of the shortened statutory period for response in the above-identified Application.

The fee for this extension is indicated below:

- One Month (\$110)
- Two Months (\$420)
- Three Months (\$950)
- Four Months (\$1,480)

Please charge the fee to deposit account no. 20-0668. Any further necessary extension of time is hereby requested. Charge any and all fees to deposit account no. 20-0668. An original and two copies of this sheet are enclosed.

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Respectfully Submitted,



Jacqueline J. Garner
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